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Practitioner's Docket No.: 939_079

IAP6 Rec'd PCT/PTO 17 AUG 2006

IN THE UNITED STATES DESIGNATED OFFICE (DO/US)

International Application No.: PCT/JP2005/002637

International Filing Date: 18 February 2005 (18.02.2005)

Earliest Priority Date Claimed: 20 February 2004 (20.02.2004)

Title of Invention: DETERGENT MADE USE OF FERMENTATION TECHNOLOGY AND PRODUCTION METHOD THEREOF

Applicant(s) for DO/US: HIGA, Teruo

Mail Stop PCT
Attention: DO/US
Commissioner for Patents
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I hereby certify that this paper or fee is being deposited with the United States Postal Service "Express Mail Post Office to Addressee" service under 37 CFR 1.10 addressed to the Mail Stop PCT, Attention: DO/US, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on August 17, 2006 under "EXPRESS MAIL" mailing label number EV 682620398 US.


Elizabeth A. VanAntwerp

INFORMATION DISCLOSURE STATEMENT

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached Form PTO-1449. Required copies of the references listed on Form PTO-1449 are attached.

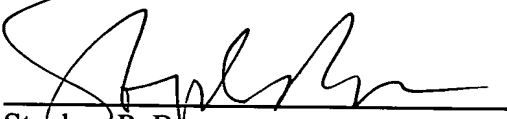
Also enclosed is a copy of an International Search Report bearing a mailing date of May 17, 2005 from a corresponding international patent application, and the U.S. PTO is directed thereto for a concise statement of possible relevance of the references cited therein.

In compliance with the concise explanation requirement under 37 CFR § 1.98(a)(3) for foreign language documents, International Publication No. WO 99/57243 A1 (Ref. AC) corresponds to U.S. Patent No. 6,649,397 (Ref. AA).

The above information is presented so that the Patent and Trademark Office may, in the first instance, determine any materiality thereof to the claimed invention. It is respectfully requested that the information be expressly considered during the prosecution of this application, and that these references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

The Commissioner is hereby authorized to charge any additional fees associated with this communication or credit any overpayment to Deposit Account No. 50-1446.

Respectfully submitted,



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August 17, 2006
Date

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Form PTO-1449 US DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i>				<i>Complete if Known</i>	
				Application Number	
				Filing Date	
				First Named Inventor	
				Art Unit	
				Examiner Name	
				Confirmation No.	
Sheet	1	of	1	Attorney Docket No.	939_079

U.S. PATENT DOCUMENTS

Exam. Initial		Document Number	Date	Name	Our Docket No.	Class	Sub Class	Filing Date
	AA	6,649,397	11-18-2003	Nakamura, Keijiro				

U.S. RELATED COPENDING APPLICATIONS

Exam. Initial		Application/ Publication Number	Filing/ Publication Date	Inventor Name	Our Docket No.	Class	Sub Class

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Sub Class	Translation	Abstract
	AB	2000-302619 A1	10-31-2000	JP			JPO Machine Translation	✓
	AC	99/57243 A1	11-11-1999	WO				
	AD	2001-026796 A1	01-30-2001	JP			JPO Machine Translation	✓
	AE	2001-032000 A1	02-06-2001	JP			JPO Machine Translation	✓
	AF	08-245992 A1	09-24-1996	JP			JPO Machine Translation	✓
	AG	2001-115200 A1	04-24-2001	JP			JPO Machine Translation	✓
	AH	2002-226893 A1	08-14-2002	JP			JPO Machine Translation	✓
	AI	08-196265 A1	08-06-1996	JP			JPO Machine Translation	✓
	AJ	08-252086 A1	10-01-1996	JP			JPO Machine Translation	✓

OTHER DOCUMENTS

(Including Author, Title, Date, Pertinent Pages etc.)

Examiner:		Date Considered:	
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EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.